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		STOCKER, MARK A	NDDEW
Notice of Allowability	10/018,767 Examiner	Art Unit	INDICEV
	Alvin J Grant	3723	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not included will be mailed in due c	d ourse. <b>THIS</b>
1. This communication is responsive to 27 May 2004.			
2. The allowed claim(s) is/are <u>1-34</u> .			
3. A The drawings filed on 19 December 2001 are accepted by	the Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority un a)  All b)  Some* c)  None of the:  1.  Certified copies of the priority documents have  2.  Certified copies of the priority documents have  3.  Copies of the certified copies of the priority documents have  International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE" on oted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.</li> <li>5.  A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give  6.  CORRECTED DRAWINGS (as "replacement sheets") must  (a)  including changes required by the Notice of Draftspers  1)  hereto or 2)  To Paper No./Mail Date  (b)  including changes required by the attached Examiner's  Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the  post attached Examiner's comment regarding REQUIREMENT is  attached Examiner's comment regarding REQUIREMENT in the  post attached Examiner's comment regarding REQUIREMENT is  attached Examiner's  at</li></ul>	been received.  been received in Application No cuments have been received in this communication to file a reply lent of this application.  itted. Note the attached EXAMINER is reason(s) why the oath or declarate be submitted.  son's Patent Drawing Review (PTO- as Amendment / Comment or in the Comment or in the Comment of BIOLOGICAL MATERIAL in the header according to 37 CFR 1.121(constitutions).	national stage application of the front (not the d).  nust be submitted. N	uirements  OTICE OF
Attachment(s)  1. Notice of References Cited (PTO-892)  2. Notice of Draftperson's Patent Drawing Review (PTO-948)  3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal P 6. ☐ Interview Summary Paper No./Mail Dat 7. ☑ Examiner's Amendr 8. ☑ Examiner's Stateme 9. ☐ Other	(PTO-413), te nent/Comment	ŕ

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## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

In the amended pages, the Abstract of Disclosure exceeds 150 words, so please amend it as follows:

- In lines 6-8, delete "The wheel is then separated......to stored data".
- In lines 12-13, delete "The profile of the.....is adjusted again".
- In line 14, change "the workpiece is repeated" to read "the workpiece are repeated".
- 2. The following is an examiner's statement of reasons for allowance: The art of record considered as a whole alone or in combination neither anticipates nor renders obvious, a method of conditioning a grinding wheel comprising grinding grit in which a groove has been formed, comprising the steps of engaging the unconditioned groove with part of the periphery of a wafer workpiece, rotating the wafer through a small angle so as to perform a shallow grind over a small arcuate extent of the rim of the wafer, disengaging the wheel from the wafer and axially shifting the wheel or the wafer before re-engaging and performing a similar grind over another arcuate region of the wafer and performing a sequence of such steps around part or all of the circumference of the wafer thereby removing bonding material from the surface of the groove in the grinding

wheel and exposing the grinding grit, and thereby condition the wheel, together in combination with the rest of the limitations set forth in the independent claims.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alvin J Grant whose telephone number is (703) 305-3315. The examiner can normally be reached on Mon-Fri 8:00-4:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph J Hail can be reached on (703) 308-2687. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Joseph J. Hail, III Supervisory Patent Examiner Technology Center 3700

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